

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Chen, et al.)	Group Art Unit Unknown
)	
Appl. No.	:	Unknown)	
)	
Filed	:	Herewith)	
)	
For :		SEMICONDUCTOR)	
		STRUCTURE WITH)	
		SUBSTANTIALLY ETCHED)	
		OXYNITRIDE DEFECTS)	
		PROTRUDING)	
		THEREFROM)	
)	
Examiner	:	Unknown)	

EXAMINER COMMUNICATION

United States Patent and Trademark Office
P.O. Box 2327
Arlington, VA 22202

Dear Sir:

This application is a divisional of U. S. Patent Application 10/234,577, filed on August 30, 2002, which is a continuation of U. S. Patent Application No. 09/738, 796, ("the parent application"), filed on December 15, 2000, which is a divisional of U. S. Patent Application No. 09/385,396, filed August 30, 1999, which is now U. S. Patent No. 6,358,788. Claims 1-49 are pending in this application.

In response to a restriction requirement in U. S. Patent Application 10/234,577, Claims 13-24, 37-48, 58-66 and 76-91 were canceled without prejudice from U. S. Patent Application 10/234,577. Claims 13-24, 37-48, 58-66 and 76-91 are renumbered as Claims 1-49 in the above-referenced application.

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CONCLUSION

In view of the forgoing, the present application is believed to be in condition for allowance, and such allowance is respectfully requested. If further issues remain to be resolved, the Examiner is cordially invited to contact the undersigned such that any remaining issues may be promptly resolved. Also, please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 7/3/03

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